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SERIAL NUMBER 10/598,488	FILING or 371(c) DATE 08/31/2006 RULE	CLASS 438	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. 70404.107/sa	
APPLICANTS Yasunobu Tagusa, Ikoma-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/04036 03/02/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-060511 03/04/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/13/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /FELISA CARLA HITESHEW/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 19	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 2
ADDRESS SHARP KABUSHIKI KAISHA C/O KEATING & BENNETT, LLP 1800 Alexander Bell Drive SUITE 200 Reston, VA 20191 UNITED STATES					
TITLE Method for fabricating a semiconductor device and apparatus for inspecting a semiconductor					
FILING FEE RECEIVED 1000	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		